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IN THE CLAIMS:

1. (original) A method of wiring formation comprising the steps of: forming a feeder film partially on a substrate;

forming on the substrate a plating base film such that the plating base film partially overlaps the feeder film;

forming a plated wiring on the plating base film; and selectively removing at least a portion of the feeder film that is exposed from the plated wiring.

- 2. (original) A method of wiring formation according to Claim 1, wherein the step of forming on the substrate a plating base film is performed using a physical film making process.
 - 3. (original) A method of wiring formation according to Claim 1, wherein the step of forming a plated wiring on the plating base film is performed using an electrolytic plating process.
 - 4. (original) A method of wiring formation according to Claim 1, wherein the step of selectively removing at least a portion of the feeder film that is exposed from the plated wiring is performed using a wet etching process.
 - 5. (original) A method of wiring formation according to Claim 1, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.
 - 6. (original) A method of wiring formation according to Claim 1, wherein the plating base film comprises at least one of an adhesive layer and a diffusion preventive layer.

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7. (original) A method of wiring formation comprising the steps of: forming a feeder film partially on a substrate;

forming on the substrate a resist pattern which has an opening defining a wiring forming area, such that a portion of the feeder film is exposed from the opening in the resist pattern;

forming a plating base film at least on the substrate in the opening; forming a plated wiring on the plating base film in the opening; removing the resist pattern; and

selectively removing at least a portion of the feeder film that is exposed from the plated wiring.

- 8. (original) A method of wiring formation according to Claim 7, wherein the step of forming on the substrate a plating base film is performed using a physical film making process.
- 9. (original) A method of wiring formation according to Claim 7, wherein the step of forming a plated wiring on the plating base film is performed using an electrolytic plating process.
- 10. (original) A method of wiring formation according to Claim 7, wherein the step of selectively removing at least a portion of the feeder film that is exposed from the plated wiring is performed using a wet etching process.
- 11. (original) A method of wiring formation according to Claim 7, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.

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- 12. (original) A method of wiring formation according to Claim 7, wherein the plating base film comprises at least one of an adhesive layer and a diffusion preventive layer.
- 13. (original) A method of manufacturing an electronic component comprising the steps of:

providing a substrate;

forming a feeder film partially on the substrate;

forming on the substrate a plating base film by using a physical film making process such that the plating base film partially overlaps the feeder film;

forming a plated wiring on the plating base film using an electrolytic plating process; and

selectively removing at least a portion of the feeder film that is exposed from the plated wiring, using a wet etching process.

- 14. (original) A method according to Claim 13, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.
- 15. (currently amended) A method according to Claim <u>4316</u>, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.
- 16. (original) A method according to Claim 13, wherein the plating base film comprises at least one of an adhesive layer and a diffusion preventive layer.
- 17. (original) A method of manufacturing an electronic component comprising the steps of:





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providing a substrate;

forming a feeder film partially on a substrate;

forming on the substrate a resist pattern which has an opening defining a wiring forming area, such that a portion of the feeder film is exposed from the opening in the resist pattern;

forming a plating base film at least on the substrate in the opening using a physical film making process;

forming a plated wiring on the plating base film in the opening using an electrolytic plating process;

removing the resist pattern; and

selectively removing at least a portion of the feeder film that is exposed from the plated wiring, using a wet etching.

All

- 18. (original) A method according to Claim 17, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.
- 19. (currently amended) A method according to Claim <u>1720</u>, wherein a width of a portion of the plating base film that is stacked on the feeder film is wider than the smallest wire width of the feeder film.
- 20. (original) A method according to Claim 17, wherein the plating base film comprises at least one of an adhesive layer and a diffusion preventive layer.
- 21. (new) A method according to Claim 1, wherein the plating base film comprises a diffusion preventive layer.
 - 22. (new) A method according to Claim 7, wherein the plating base film

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comprises a diffusion preventive layer.

- 23. (new) A method according to Claim 13, wherein the plating base film comprises a diffusion preventive layer.
- 24. (new) A method according to Claim 17, wherein the plating base film comprises a diffusion preventive layer.
- 25. (new) A method according to Claim 1, further comprising a step of forming on the substrate a resist pattern having a reversed taped shape.
- 26. (new) A method according to Claim 1, wherein the plating base film comprises an adhesive layer.

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